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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Iwao Hatanaka

Art Unit: 2141

Serial Number: 09/781,616

Examiner: Luu, Le Hien

Filing Date: 02/12/2001

Docket No.: CHA9-99-015

Title: METHOD AND SYSTEM FOR AUTOMATED SESSION RESOURCE
CLEAN-UP IN A DISTRIBUTED CLIENT-SERVER ENVIRONMENT

COMMISSIONER FOR PATENTS

DESTINATION FACSIMILE NUMBER: 571-273-8300

Transmitted herewith is: **Amendment in 9 pages**

in the above identified application.

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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

I. Introductory Comments

This paper is being filed in response to the Office Action dated July 18, 2005. Please amend the above-referenced patent application as follows: